

Docket No.: LGS/P-175

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:
	:
Ho Hyun KIM	: Allowed: February 22, 2002
	:
Serial No.: 09/281,973	: Group Art Unit: 2133
	:
Confirm. No.: 7981	: Examiner: P. Chung
	:
Filed: March 31, 1999	:
	:
For: TEST MODE SETUP CIRCUIT FOR MICROCONTROLLER UNIT	

**CONFIRMATION OF FILED CERTIFIED COPY
OF PRIORITY DOCUMENT**

Assistant Commissioner for Patents
Washington, D. C. 20231

Sir:

The Notice of Allowability dated February 22, 2002 acknowledges receipt of the Certified Copy of the Priority Document for the above-identified application. However, the Notice of Allowability does not check box 4 a) to indicate that "All" of the documents have been received. Accordingly, the Notice of Allowability should have indicated that "All" of the Certified Priority Documents were received.

Serial. No. 09/281,973

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Thus, Applicant believes that no further action is required to obtain priority to Korean Patent Application 17228/1998, filed May 13, 1998 in the Republic of Korea, for the above-identified application. The Patent Office is requested to contact Applicant's undersigned attorney if this is incorrect.

Respectfully submitted,
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